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Signature & date

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of \_\_\_\_\_ :

July 8, 2003

M Khare, et al. :

Group Art Unit: 2823

Serial No. 09/809,663 :

Examiner: Fernando L. Toledo

Filed: 3/15/2001 :

International Business Machines Corporation  
2070 Route 52  
Hopewell Junction, NY 12533

**TITLE:** METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA THIN GATE DIELECTRICS

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the prior patents and publications as listed on Form PTO-1449, attached hereto.

Each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

Pursuant to 37 C.F.R. § 1.97(c)(1), no fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,  
M. Khare, et al.

By Margaret A. Pepper  
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# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

FIS92000039

Application Number

09/809,663

Applicant(s)

M, KHARE, ET AL.

Filing Date

3/15/01

Group Art Unit

2823

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	PUPA 2001-85427	3/30/2001	JAPAN				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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Docket No. FIS920000396

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Inventors M. Khare, et al.

Title METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA THIN GATE DIELECTRICS

Atty MAP

# of Pages

Application 2 Transmittal Sheet

Assignment Spec/Claims/Abstract

No. of Claims \_\_\_\_\_ Drawings

Declaration/POA



PCT Application \_\_\_\_\_

Transmittal

PCT Request

Fee Sheet

Power of Attorney

Description

Abstract

Claims

Drawings

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Issue Fee - # of pages \_\_\_\_\_

Other \_\_\_\_\_